

Accepted Manuscript

Influence of Si content on the wettability and corrosion resistance of nanocomposite TiSiN films deposited by pulsed-DC PACVD

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PII: S0925-8388(17)34431-6

DOI: [10.1016/j.jallcom.2017.12.235](https://doi.org/10.1016/j.jallcom.2017.12.235)

Reference: JALCOM 44321

To appear in: *Journal of Alloys and Compounds*

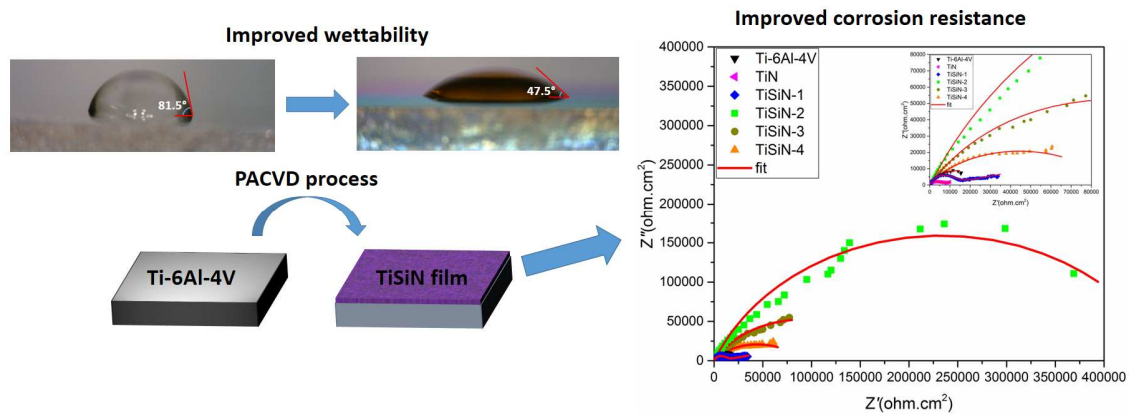
Received Date: 31 October 2017

Revised Date: 12 December 2017

Accepted Date: 22 December 2017

Please cite this article as: F. Movassagh-Alanagh, A. Abdollah-zadeh, M. Asgari, M.A. Ghaffari, Influence of Si content on the wettability and corrosion resistance of nanocomposite TiSiN films deposited by pulsed-DC PACVD, *Journal of Alloys and Compounds* (2018), doi: 10.1016/j.jallcom.2017.12.235.

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